2812

RECEIVED

PATENT APPLICATION

RK OFFICE

35.C15122

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pre Application of:

SHIGENORI ISHIHARA

Application No.: 09/779,645

Filed: February 9, 2001

For:

ORGANIC SUBSTANCE REMOVING METHODS, METHODS OF PRODUCING SEMICONDUCTOR DEVICE,

AND ORGANIC SUBSTANCE REMOVING APPARATUSES

Examiner: Not Yet Assigned

Group Art Unit: 2812

July 2, 2001

TO TAGO

Commissioner for Patents Washington, D.C. 20231

SECOND INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicant Registration No. 29, 767

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200

| FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE | | | ATTY DOCKET NO. 35.C15122 | APPLICATION NO. 09/779,645 | | | |
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| ļ | | OTHER DOCUMENT | (S) (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | |
| | S. Fujimura et al., "Ion Implantation Change in the Chemical Structure of a Resist", Nucl ar Instruments and Methods in Physics Research B39 (1989), pp. 809-812. | | | | | | |
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Sheet_1_ of _1_

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.